Docket No: 740819-1028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Patent Application of)
Hiroshi YUASA)
Based On Application No. 09/790,518) Art Unit: 2814
Which Was Filed: February 23, 2001) Examiner: A. Mai
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR FABRICATING THE SAME) Date: October 30, 2003

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/790,518 filed February 23, 2001, from which priority is claimed under 35 U.S.C. 120.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

Donald P. Stude

Donald R. Studebaker Registration No. 32,815

NIXON PEABODY LLP 401 9th Street, N.W. Suite 900 Washington, D.C. 20004-2128 (202) 585-8000

Complete if Known Substitute for form 1449A/PTO Application Number **New Application** INFORMATION DISCLOSURE October 30, 2003 Filing Date STATEMENT BY APPLICANT Hiroshi YUASA First Named Inventor (use as many sheets as necessary) 2814 Art Unit Anh D. Mai Examiner Name 1 Sheet Attorney Docket Number 740819-1028

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-6,365,528 B1	04/02/2002	Sukharev et al.	
		US-6,472,755 B1	10/29/2002	Ngo et al.	
		US-6,350,670 B1	02/26/2002	Andedih et al.	
		US-2002/0034874	03/21/2002	Aoki	

		FC	DREIGN PATENT D	OCUMENTS		
Examiner Initials*	Cite No. ¹	Foreign Patent Document Kind Code ⁵ Country Code ³ Number ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
		JP 11-87503	03/30/1999	Ohashi et al.		Abstract
		JP 11-297829	10/29/1999	Yokoyama et al.		Abstract
		JP 2000-58642	02/25/2000	Kojima et al.		Abstract
		JP 6-216116	08/05/1994	Sasaki		Abstract
		JP 9-275138	10/21/1997	Matsunou		Abstract
		JP 2002-26121	01/25/2002	Maekawa et al.		Abstract
		OTHER PRIOR	ART – NON PATENT L	ITERATURE DOCUMENTS		
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.				
		S. Wolf et al., "Silicon Pro	cessing for the VI	SI Era", Vol. 1, 1986 La	attice Press, p. 18	4.
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Examiner	Date	
Signature	 Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.